INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 22, 2026

IGI Report Number	LG848665783
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND MODIFIED BRILLIANT
Measurements	6.26 - 6.33 X 3.79 MM

GRADING RESULTS

Carat Weight	1.01 CARAT
Color Grade	F
Clarity Grade	VS 1

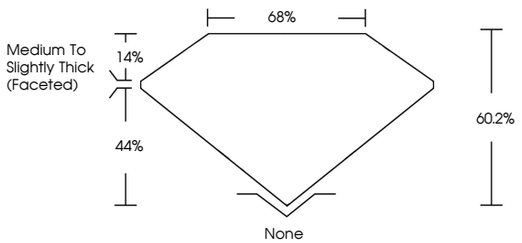
ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	IGI LG848665783

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG848665783
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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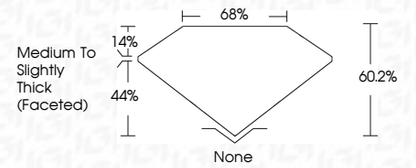
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IGI

October 22, 2026
IGI Report No LG848665783
ROUND MODIFIED BRILLIANT
6.26 - 6.33 X 3.79 MM
Carat Weight 1.01 CARAT
Color Grade F
Clarity Grade VS 1
Depth 60.2%
Table 68%
Girdle Medium To Slightly Thick (Faceted)
Culet None
Polish VERY GOOD
Symmetry VERY GOOD
Fluorescence NONE
Inscription(s) IGI LG848665783
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa